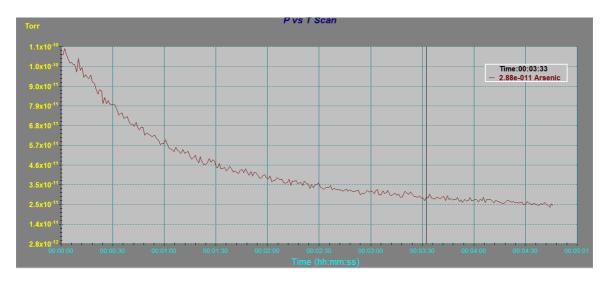
Aluminum Cell at 980. As cell 370/600

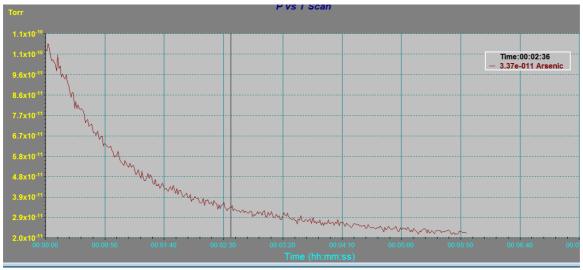
Opened As shutter and valve for 15 minutes which is roughly what I grow the inas layers of the topological insulators at

Going to record the beam flux monitor (holstered) and the RGA After the cutting off the As to see how long it decays as well as Ion Gauge pressure

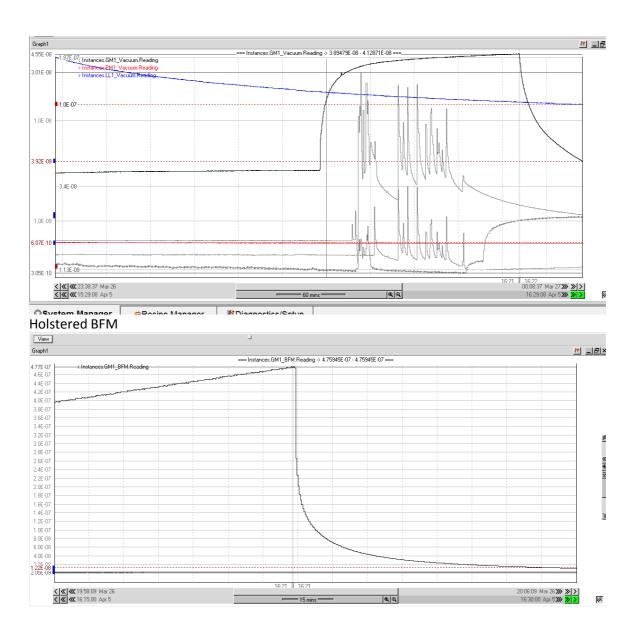
Then do the same with aluminum beam coming out

No aluminum





Chamber ion gauge



Now 15 more mins with As shutter and valve open to see if the slope is sharper

